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Grain boundary effect unveiled in monolayer MoS₂ for photonic neuromorphic applications†

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Layered 2D materials with grain boundaries (GBs) hold promise for various applications. Despite considerable progress, deliberately introducing GBs remains a challenge during 2D material growth. In this study, we explored the significance of GBs in monolayer molybdenum disulfide (ML MoS₂) in optoelectronic functionalities such as photo-detection, photonic synaptic behaviours, and adaptive learning analogous to the brain. Our comparative analysis revealed that GB-free MoS₂ devices demonstrated a superior photodetector performance, featuring a remarkably high dark-to-light current ratio of 10⁵ at -1.0 V, with responsivity reaching 10 A W⁻¹, detectivity soaring to 10¹⁵ W⁻¹, and a noise equivalent power of about 10⁻¹⁶ W $\sqrt{\text{Hz}}$ ⁻¹, outperforming devices containing GBs. Moreover, GBs significantly delayed the response speed, indicating the prevalence of persistent photoconductance. Conversely, GBs facilitated the replication of various optoelectronic synaptic behaviors and adaptive learning of the brain. Our experimental results uncovered the sharp and robust atomic stitching of MoS₂ domains at GBs, which act as charge carrier recombination centers due to the presence of defects. Notably, GBs induced a barrier within the energy bands by shrinking the bandgap, hindering the flow of photogenerated carriers. We systematically elucidated this phenomenon through energy band diagrams and electrostatic force microscopy results from biased samples under illumination.

1. Introduction

The field of neuromorphic computing has seen significant progress, with ongoing research and development efforts aimed at creating novel devices and architectures using different advanced and smart materials.^{1–4} In traditional computing, information is processed using a central processing unit (CPU) based on the von Neumann architecture, which separates memory and processing units.⁵ Neuromorphic computing conversely

aims to mimic the parallel processing and learning capabilities observed in the brain. Devices for neuromorphic computing are classified into various types based on criteria such as their architecture, operation principles, materials used, and application areas.^{6–8} Accordingly, a photonic memristor or optoelectronic neuromorphic device is a type of device that combines the principles of neuromorphic functionalities and optoelectronics using light (photons), which is quite complex to design.^{9,10} They offer low-power memory storage and computation, paving the way for more efficient artificial intelligence systems and next-generation optical communication technologies.¹¹ Interestingly, two-dimensional transition metal dichalcogenides (2D TMDCs), such as molybdenum disulfide (MoS₂), rhenium disulphide (ReS₂), and tungsten disulphide (WS₂), play a significant role in the design of photonic neuromorphic devices due to their high absorption coefficient, ultrafast carrier dynamics, and non-linear optical properties.^{7,12} Photonic neuromorphic devices leverage the unique properties of 2D TMDCs to achieve efficient light-matter interaction and mimic certain aspects of neural processing similar to that in our brain.^{3,10,13}

Since the discovery of graphene in 2004 using scotch-tape exfoliation, a similar strategy was adopted to isolate the monolayer from the bulk crystal of TMDCs to open up a new realm of possibilities.¹⁴ Later, techniques such as liquid-phase exfoliation, redox exfoliation, hydrothermal growth, and chemical vapour deposition (CVD) were adopted to grow the monolayer to a few layers of 2D TMDCs.^{15–17} Because of scalability and quality, the CVD technique has been used to grow high-quality large-area 2D TMDCs on different substrates, including Si/SiO₂ and quartz. In general, CVD-grown 2D TMDCs depict the polycrystalline nature of the assembly of multiple domains, which are stitched by the well-defined grain boundaries (GBs) originating from the presence of defects such as dislocations, vacancies, and dangling bonds.^{18,19} GBs in 2D layered materials significantly affect the electronic and optical properties as the centres of carrier scattering and recombination. The effect of GBs on 2D layered material devices remains a long-lasting topic of interest in materials science and nanotechnology to

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demonstrate exciting applications.²⁰ Previously, 2D TMDCs have been investigated for developing devices, such as transistors, photodetectors, sensors, memristors, and catalytic electrodes, but the GB effect is mostly ignored. The lack of knowledge of the GB effect in 2D layered TMDCs limits many potential applications, including the merging of optoelectronics and neuromorphic computing.^{21,22}

In this study, we grow 2D monolayer (ML) MoS₂ of different shapes using the CVD technique at a relatively lower temperature, and sodium chloride (NaCl) is used as the seeding promoter. Systematic characterizations reveal that the MoS₂ flakes of a triangular shape are single crystalline. However, the shapes of four and six-point stars of MoS₂ contain sharp GBs, which are further characterized to reveal the elemental composition, scattering nature, optical emission, and structural properties of MoS₂ GBs step-by-step.²³ To reveal the effect of GBs on the optoelectronic property, a planar device of metal/semiconductor/metal (MSM) structure was fabricated using MoS₂ samples of triangular and six-point star shapes. Then, current–voltage characteristics, both the DC sweep and temporal, were recorded under dark and light of varying intensities for both devices, and various photodetector performance parameters were estimated, including responsivity (R), detectivity (D), signal-to-noise ratio (SNR), and noise equivalent power (NEP). An advanced AFM mode, such as electrostatic force microscopy (EFM), is used to visualize the role of GBs precisely. Interestingly, the MSM device of ML MoS₂ with GBs shows various optoelectronic synaptic actions and adaptive learning behaviour of the brain.

2. Results and discussion

2.1. Growth and characterization of MoS₂ and GB-mediated MoS₂

To probe the property of the grain boundary (GB) present in monolayer molybdenum disulphide (ML MoS₂) and how it modulates the optoelectronic device functionality and related applications, a controlled growth process is crucial for intentionally incorporating GBs into the samples. For that, we utilize a slightly modified chemical vapour deposition (CVD) technique, as reported elsewhere, at a relatively lower growth temperature (600 °C) in the presence of NaCl seeding promoter.^{17,23,24} Accordingly, we successfully demonstrated a recipe for growing monolayer MoS₂ samples of different shapes on the Si/SiO₂ substrates based on the strategy of locating substrates inside the growth chamber relative to the seeding promoter NaCl and Mo-precursor, as illustrated in Fig. S1 in the ESI.† Fig. 1(a–c) depicts the recorded optical microscope (OM) images of the CVD-grown ML MoS₂ samples of shapes, such as triangular, four-point star, and six-point star, respectively. These OM images appear almost uniform in contrast and might be monocrystalline. However, a different nature is discovered after recording the SEM images due to the appearance of GB. Particularly, the triangular MoS₂ flake appears GB-free (Fig. 1d), and the other two samples contain sharp GB stitched between domains (Fig. 1e and f). It would be intriguing to investigate further the origin of GB in these CVD-grown ML MoS₂ samples and reveal the possible mechanism of shape evaluation systematically. Eventually, we recorded the photoluminescence (PL) mapping

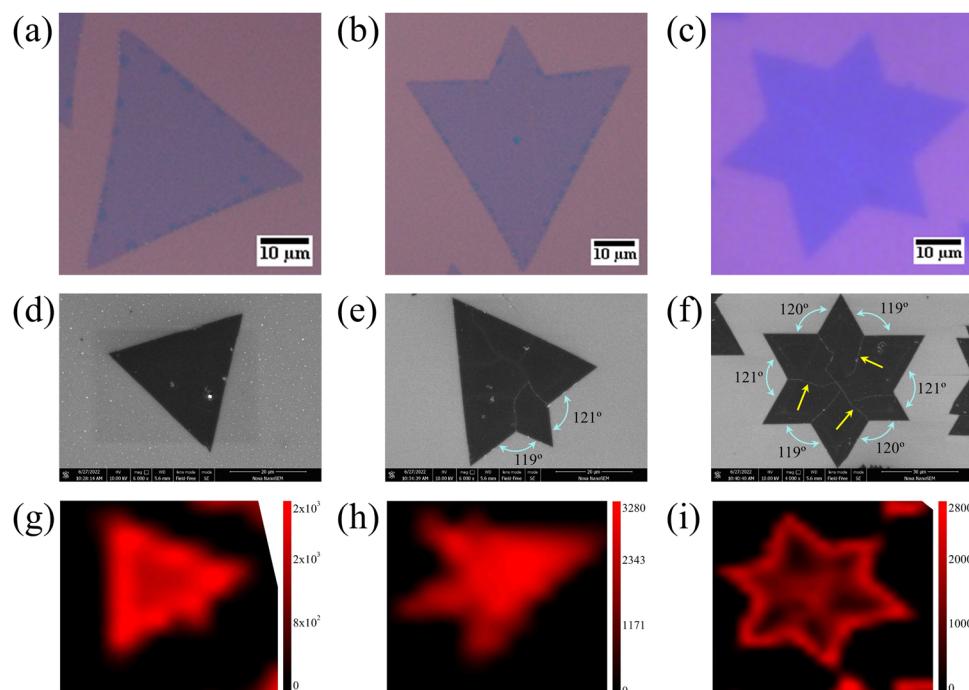


Fig. 1 (a)–(c) Optical microscope image of the grown MoS₂ samples starting from the three-point star to the six-point star. (d)–(f) Scanning electron microscope image of the grown MoS₂ samples. (g)–(i) Photoluminescence (PL) mapping of MoS₂ samples recorded by exciting with a light wavelength of 532 nm.



images of the above samples, as shown in Fig. 1(g–i), and found an interesting correlation between the GBs and bright PL spots. Despite having bright PL regions at the edges of the triangular ML MoS₂ sample (Fig. 1g), the GBs are also bright in the PL mapping images of the four-point and six-point star samples, as depicted in Fig. 1h and i, respectively. Usually, the edges are vacancy-dominated in terms of missing atoms, dangling bonds, and defects in the crystal lattice structure, which were found more efficient to emit the absorbed photons by serving as radiative recombination centers for the photogenerated charge carriers, which are further modulated by the intrinsic strain existing at the GBs.²³ The monolayer thickness of these MoS₂ samples is strongly supported by the recorded AFM topography images, and the thickness is found to be mostly about 1 nm, as shown in Fig. S2 in the ESI.[†]

The growth conditions, including temperature, pressure, and precursor flow rates, play a crucial role in determining the final shape and size of the MoS₂ flakes in the CVD process. In this technique, molybdenum and sulfur precursors are vaporized and transported to a prepared substrate in the presence of a NaCl seeding promoter. Typically, MoS₂ nucleates first on the substrate, forming islands that grow through the addition of more molybdenum and sulfur atoms. The mechanism behind this shape evolution is strongly influenced by the molybdenum : sulfur (Mo : S) precursor ratio, along with the growth rate of different faces of the nucleated sites.²³ Generally, the faces that grow quickly either shrink or vanish completely, while the slower faces eventually grow to larger dimensions. Moreover, the growth rate is determined by the surface free energy, which is higher at a slower rate. In our experiment, the Si/SiO₂ substrate positioned closest to the NaCl catalyst exhibited the highest coverage of MoS₂ flakes with a six-point star shape featuring 12 vertices. As the distance increases, the density of flakes decreases, accompanied by a reduction in the number of vertices in the shapes, as depicted by the recorded optical images of the three substrates in Fig. S1 in the ESI.[†] NaCl acts as a catalyst in the CVD process, enhancing MoS₂ growth by lowering the reaction energy barrier, improving grain size and crystalline quality, aiding precursor vaporization, and increasing nucleation, with effects dependent on substrate, temperature, and growth rate. For instance, the four-point star exhibits six vertices, whereas the triangular MoS₂ displays three vertices. Interestingly, the shape evaluation resulted in an angle of $120^\circ \pm 0.9^\circ$ at the inner vertex connecting the two outer vertices, as depicted in Fig. 1e and f. This angle ideally should be 120° for a perfect six-point star or hexagram due to the overlapping of two equilateral triangles.¹⁸ The slight deviation might originate during the stitching process of two or more domains to form the grain boundaries (GBs). Notably, the height profiles extracted from the recorded AFM topography images, as shown in Fig. S2 in the ESI,[†] are almost flat. This indicates that the GB interfaces are strongly coupled or faceted at the same plane and not abrupt or overlapped crystal interfaces, as observed earlier in graphene and MoS₂.^{25,26}

Comprehending the significance of edges and grain boundaries in MoS₂ holds paramount importance in tailoring its optical properties for diverse applications, including optoelectronics and

photodetectors. Manipulating these structural features provides researchers with the potential to enhance the efficiency of photoluminescence (PL) and finely tune the emitted light spectrum, thereby unlocking possibilities for advanced device design and seamless integration. In conjunction with optical microscopy (OM) and scanning electron microscopy (SEM) studies, we conducted photoluminescence (PL) and Raman scattering measurements to probe the optical and scattering properties of our MoS₂ samples. The PL mapping images in Fig. 1(f and g) depict monolayer (ML) MoS₂ samples with shapes resembling triangles, four-point stars, and six-point stars. Remarkably, the edge sites of all the samples exhibit a striking brightness, indicating high sensitivity to PL emission. This brightness correlates with the presence of defects, specifically sulfur vacancies and dangling bonds. In the case of the four-point star, characterized by a network-like arrangement of grain boundaries (GBs), the entire flake appears uniformly bright. Conversely, the six-point star reveals bright PL regions along the interior of the GBs within the flake, strongly supporting the presence of defects attributable to sulfur vacancies and dangling bonds.²⁷ Surprisingly, the recorded Raman mapping images in Fig. S3 in the ESI[†] do not display a clear contrast difference for the entire flake across all three shapes. This observation underscores the need for further controlled experiments to identify and understand the scattering properties of the grain boundaries. Unravelling these intricate details is crucial for advancing our understanding of MoS₂ behaviour and optimizing its utility in emerging technologies.

In addition to Raman and PL mapping, we also conducted recordings of the Raman and photoluminescence (PL) signal spectra for the six-point star sample, both at and away from the grain boundary (GB). In Fig. 2a, the recorded Raman scattering spectrum at a location far from the GB is presented. This spectrum exhibits two prominent peaks: one for the out-of-plane A_{1g} mode at 403.84 cm^{-1} and another for the in-plane E_{2g}¹ mode at 384.09 cm^{-1} . The separation between these peaks is 19.75 cm^{-1} , indicating the monolayer thickness of our chemical vapour deposition (CVD) grown MoS₂ samples.²⁸ Remarkably, the Raman spectrum recorded over the same MoS₂ sample at the grain boundary (GB) reveals a peak separation of approximately 21.55 cm^{-1} , attributed to a red shift of the E_{2g}¹ mode by 1.80 cm^{-1} . This shift strongly indicates the constraint of in-plane vibrations due to the robust stitching of the two domains at their boundaries. Furthermore, the line shape asymmetry and the full-width half-maximum (FWHM) of both Raman modes exhibit noticeable increases at the GB, as illustrated in Fig. 2a and Fig. S4a, b in the ESI,[†] respectively. The observed line-shape asymmetry in Raman modes of nanostructured crystalline materials is primarily associated with translational symmetry breaking at grain boundaries. Additionally, this asymmetry may arise due to the interference between the discrete vibrational mode and a continuum of background states, as introduced in the concept of Fano resonance.^{29,30} Accordingly, the GB in the monolayer MoS₂ sample highlights distinct features compared to the domains, highlighting pronounced differences in Fano resonance and a reduced phonon lifetime in the presence of defects.



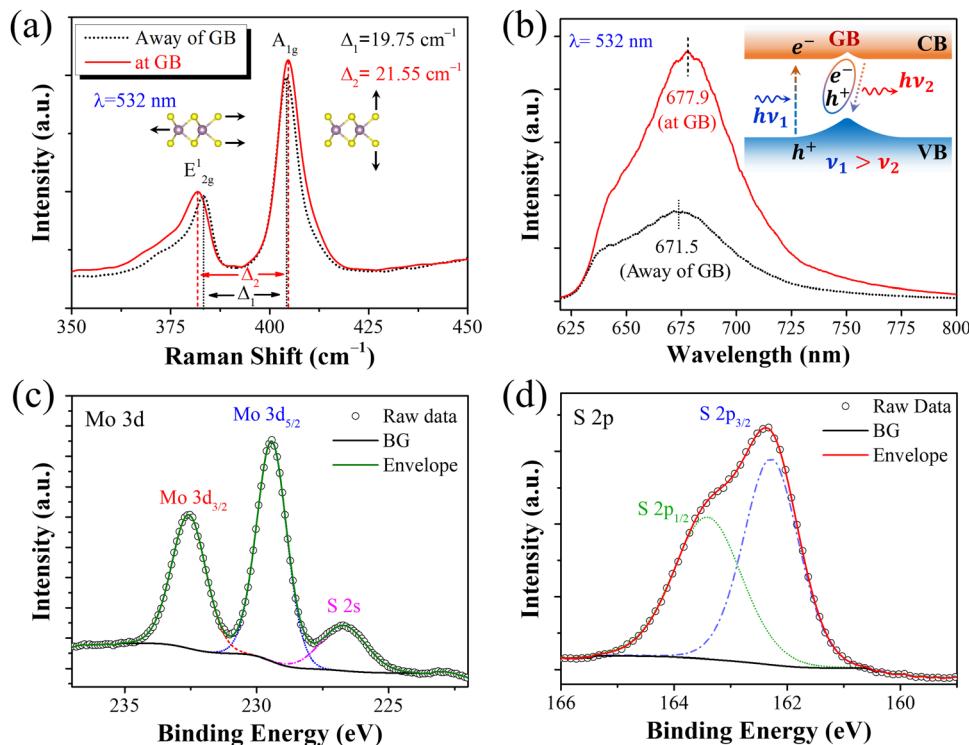


Fig. 2 (a) and (b) Raman and photoluminescence spectra of the MoS₂ sample were recorded by exciting with a light wavelength of 532 nm in the interior and at the GB. (c) and (d) High-resolution XPS spectra of Mo and S, respectively.

Furthermore, we precisely examined the optical property variations of MoS₂ at and away from the GB by meticulously recording the PL spectra at these specific locations, as illustrated in Fig. 2b. The emission line at the location away from the GB is observed at 671.5 nm, while it experiences a redshift to 677.9 nm at the GB. This shift indicates a reduction in the band gap at the GB of the six-point monolayer MoS₂.²⁰ Consequently, we propose a potential energy band diagram by considering the lower energy band gap at the grain boundary, as depicted in the inset in Fig. 2b, aligning with previously reported studies.³¹ Notably, the broader appearance of the PL spectra is attributed to the high spatial resolution of Raman microscopy. This high resolution enables the sampling of different regions within the sample, contributing to the overall spectrum.

The subsequent investigation aimed to explore the elemental composition of the six-point star monolayer (ML) MoS₂ sample utilizing X-ray photoelectron spectroscopy (XPS) techniques. The recorded survey spectrum, depicted in Fig. S5a in the ESI,† comprehensively captured all major binding energy (BE) peaks corresponding to the elements molybdenum (Mo) and sulfur (S) in MoS₂. To mitigate the charging effect on the sample, all associated elemental spectra underwent conventional calibration before the initiation of peak analysis using the C 1s BE peak at 284.5 eV as a reference point, originating from the presence of organic contamination. For enhanced precision, high-resolution (HR) XPS spectra were acquired for the Mo 3d and S 2p electrons, as illustrated in Fig. 2c and d, respectively. Deconvolution of the Mo 3d electron spectrum (Fig. 2c) revealed spin-orbit coupling-

mediated doublet splitting, with BE peaks centered at 229.4 eV and 232.5 eV for the Mo 3d_{5/2} and 3d_{3/2} lines, respectively. Similarly, deconvolution of the HR XPS spectrum for the S 2p electrons exhibited doublet splitting under spin-orbit coupling, with BE peaks centered at 162.2 eV and 163.4 eV for the S 2p_{3/2} and 2p_{1/2} lines, respectively. The high-resolution spectrum of O 1s electrons shows a BE peak centered at 532.7 eV without any additional peak, as shown in Fig. S5b in the ESI,† which actually originates from the Si/SiO₂ substrate. Importantly, all these BE positions for the elemental composition of our MoS₂ sample align seamlessly with the National Institute of Standard and Technology (NIST) database.³² Thus, the growth and composition of our chemical vapour deposition (CVD)-grown ML MoS₂ sample are robustly confirmed, supported by the systematic analysis conducted through XPS.

To elucidate the structure and crystal orientation of the two MoS₂ domains at the grain boundary (GB) in the six-point star-shaped sample, atomic-scale investigations were conducted using a transmission electron microscope (TEM), as illustrated in Fig. 3.^{18,23} The low-resolution TEM image recorded near the leg region of our six-point star sample reveals the ultrathin nature of monolayer (ML) thickness without any clear signature of the GB (Fig. 3a). For a more precise investigation, a high-resolution (HR) TEM image near a GB region and a selected area electron diffraction (SAED) pattern were recorded, as depicted in Fig. 3b and c, respectively. The SAED pattern displays three consecutive encircled diffraction spots with inter-planar d-spacing values of 2.7, 1.6, and 1.37 Å. These d-spacing values were utilized to identify the lattice planes using

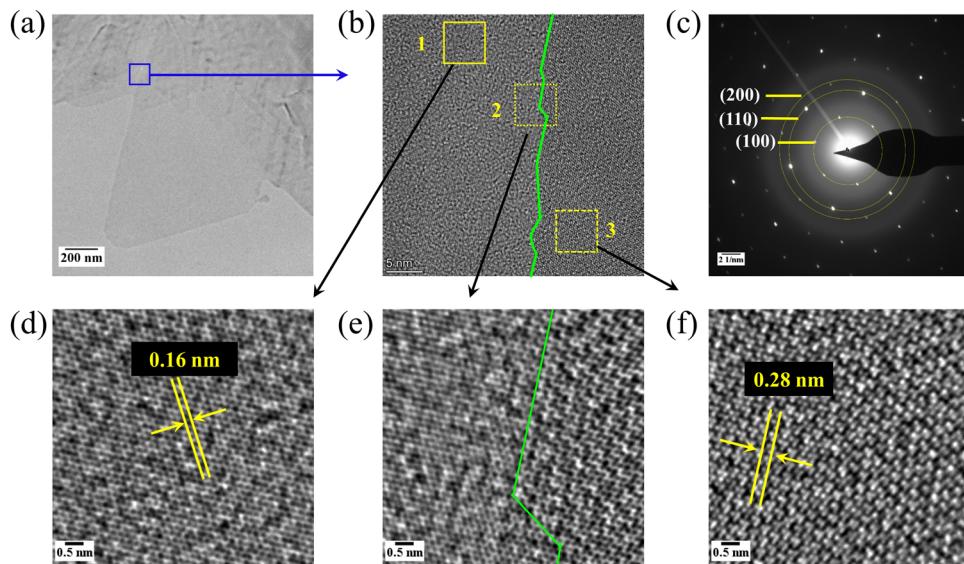


Fig. 3 (a) Low-resolution TEM image of the six-point star of MoS₂. (b) High-resolution transmission electron microscopy image of monolayer MoS₂ marked three different regions across the GBs as 1, 2 and 3. (c) Selected area electron diffraction (SAED) pattern of the MoS₂ sample as shown in the blue square region in (a) showing periodic bright diffraction spots similar to a monocrystalline phase. (d)–(f) HR-TEM images of 1, 2 and 3 regions, respectively.

the ICDD database PDF number 00-037-1492, corresponding to (100), (110), and (200) planes, as illustrated in Fig. 3c. The atomic packing of the six-point star MoS₂ with the GB was investigated more precisely by recording the HR-TEM images of three different smaller regions marked in Fig. 3b. Interestingly, the MoS₂ flake appears continuous across the GB, but the crystal plane orientation is found to be entirely different across the domains with sharp stitching.^{18,20} This observation signifies no discontinuity in the lattice structure within each grain at the boundary but shows a completely different orientation, as illustrated by the HR-TEM images in Fig. 3(d–f). Fig. 3d shows an HR-TEM image recorded on the left side of the GB at marked location 1 in Fig. 3b, depicting a *d*-spacing of 0.16 nm for the lattice plane (110). Similarly, the marked location 3 to the right side of the GB shows a *d*-spacing of 0.28 nm for the lattice plane (100), as shown in Fig. 3f.²³ Therefore, these HR-TEM images and related analyses strongly confirm the structure of the GB at the atomic scale resolution in the CVD-grown six-point star monolayer MoS₂ sample, as depicted in Fig. 3e.

2.2. Influence of GB on optoelectronic properties of MoS₂

To investigate the influence of GBs on the electrical and optoelectronic properties of ML MoS₂, two planar devices were fabricated by employing a photolithography technique for patterning Cr/Au electrodes on top. Accordingly, a six-point star sample is used to fabricate a device with the specified structure: Au/GB-MoS₂/Au. In this design, a GB is intentionally positioned between the electrodes, as demonstrated in Fig. 4a, utilizing an SEM image of an actual device and labelled as [A]. Conversely, another controlled device with a similar architecture to [A] is fabricated using a GB-free triangular ML MoS₂ flake sample, as depicted in Fig. 4b of structure Au/MoS₂/Au,

and denoted as [B]. Then, these devices were characterized by measuring the current–voltage (*I*–*V*) characteristics in the ambient atmosphere by sweeping voltage from -1.0 V to $+1.0$ V in steps of 10 mV under both the dark and light illumination, as shown in Fig. 4c. The device [B] without GB shows a dark-to-light current ratio ($I_{\text{light}}/I_{\text{dark}}$) of about 10^5 at -1.0 V, which is reduced to 10^3 for the device [A]. A mild rectification is observed in the recorded dark current (I_{dark}) for the device [B], which mostly originates from the difference of resistance between the contacts as other device parameters are symmetric. Interestingly, device [A] shows a much higher I_{dark} than device [B], almost symmetric, which indicates the suppression of contact resistance difference in the presence of GB. This also indicates a significant contribution from the thermally generated carriers in the presence of defects and reduced band gap energy at the GBs.³³ Conversely, the current under light (I_{light}) is found to be much lower in [A], which again indicates the presence of additional load induced by the GB and thermal carrier-induced combination loss of photo-generated carriers. These photoconduction results clearly reflect that the GB-free MoS₂ would be a better choice for high-performance photodetector design as found for the device [B].³⁴

The temporal response of a photodetector is intricately linked to the dynamics of photo-generated charge carriers, wherein the electrical current through the device evolves in response to variations in the incident light illumination period. To investigate this, the temporal responses of devices [A] and [B] were documented by subjecting them to a light pulse of a specific width (t_w), as illustrated in Fig. 4d and e, respectively. Notably, a significant disparity in response speed is evident in the presence of GBs in the MoS₂ device. In particular, device [A] exhibits a rise time (τ_{rise}) of 12.88 s, contrasting with the 256 ms rise time for [B] in the absence of GB. Similarly, the fall time

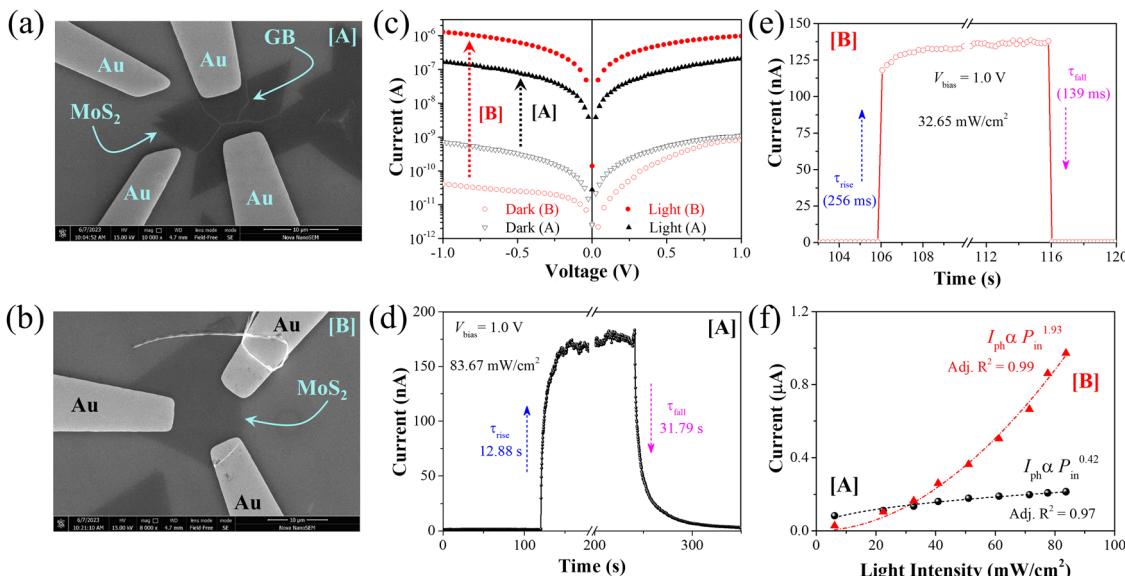


Fig. 4 (a) and (b) Scanning electron microscopy image of devices [A] and [B] fabricated on Si/SiO₂ substrates. (c) Current–voltage (I – V) characteristics of the *in situ* MoS₂ photodetectors were recorded under ambient condition by exposing them to white light with an intensity of 83.67 mW cm^{-2} and in the dark. (d) and (e) Response time of devices [A] and [B], respectively, at a bias of $+1 \text{ V}$ and light intensities of 83.67 mW cm^{-2} and 32.65 mW cm^{-2} . (f) Variation in the photocurrent (I_{ph}) with light intensities.

(τ_{fall}) is 31.79 s for [A] but reduces to 139 ms for [B] in the presence of a persistent photoconductive (PPC) effect in [A]. The delayed response of [A] is attributed to the slower carrier dynamics influenced by the presence of GB, which introduces defect centers that affect carrier recombination, scattering, and trapping–detraping processes. Furthermore, the light intensity-dependent photocurrent ($I_{\text{ph}} = I_{\text{light}} - I_{\text{dark}}$) responses are recorded for both devices, as depicted in Fig. 4f. These responses adhere to a power-law relationship represented by the equation $I_{\text{ph}} \propto P_{\text{in}}^{\alpha}$, where α is a constant exponent typically found to be unity or less in traditional photodetectors.^{33,35} For [A], the exponent value is approximately 0.42 , indicating a complex photo-generated charge carrier recombination process induced by the defects in GB, as observed earlier. Conversely, [B] exhibits α value of around 1.93 , suggesting the presence of a giant superlinear power law dependence of light intensity due to the photothermal effect.^{36,37} To highlight the performance of both devices, we conventionally estimate the responsivity (R) and specific detectivity (D^*) by varying the incident light intensities, as depicted in Fig. S6 in the ESI.^{†,38} The performance parameters for both devices are detailed in Table 1, encompassing R , D , signal-to-noise ratio (SNR), noise equivalent power (NEP), and

other relevant metrics for a particular intensity of light. The significance of this work is further emphasized by comparing its performance with similar studies, as shown in Table 2. This comparison clearly demonstrates a low-voltage operation with notable photonic synaptic activities (PSA) of the lateral Au/GB-MoS₂/Au device.

2.3. Carrier dynamics direct evidence from electrostatic force microscopy (EFM) measurement

Exploring the impact of photo-generated carrier dynamics in illuminated MoS₂ samples with and without GBs would be intriguing through direct examination using the electrostatic force microscopy (EFM) technique at the nanoscale.⁴⁵ The EFM technique facilitates the measurement of the electrostatic frictional force between the sample surface and a biased atomic force microscopy (AFM) tip, which can be modulated further by applying a sample bias voltage and light illumination.²¹ To uncover the role of GBs in our planar MSM devices, we performed EFM testing in a combination of sample biasing and light illumination, as shown in Fig. 5a. An AFM topography image of device [A] clearly depicts the presence of GBs in the ML MoS₂ sample between the two metal contacts, as shown in

Table 1 Performance parameter comparison between devices [A] and [B]. All required calculations are included in Section S1 of the ESI

Parameters	[A]	[B]
$I_{\text{dark}} (1.0 \text{ V}) (\text{nA})$	1.1	0.8
$I_{\text{light}}/I_{\text{dark}} (1.0 \text{ V})$	1.9×10^2	1.2×10^3
τ_{rise} and τ_{fall} (ms)	12 880 and 31 900	256 and 139
Responsivity (R) at 83.67 mW cm^{-2} (A W^{-1})	7.7	27.3
Detectivity (D) at 83.67 mW cm^{-2} ($/\text{W}$)	2.2×10^{15}	2.3×10^{15}
SNR (dB)	154.6	140.9
NEP ($\times 10^{-16} \text{ W} \sqrt{\text{Hz}}^{-1}$) at 83.67 mW cm^{-2}	27.9	3.8



Table 2 Optoelectronic performance metrics achieved in this work are compared with those of previous reports of similar types without accounting for some parameters due to non-availability, such as NEP ($\text{W} \sqrt{\text{Hz}}^{-1}$), SNR (dB), and classical conditioning

Device detail	Switching control	Rise/fall time	Operating voltage (V)	I_{dark} (A)	$I_{\text{light}}/I_{\text{dark}}$	R (mA W^{-1})	D^* (Jones)	PSA	Ref.
W/MoS ₂ /p-Si (Vertical)	Optical	—	−8.0 to +8.0	10^{-8}	3	—	—	Yes	39
Ti/PdSe ₂ /Au (Vertical, GB)	Electrical	—	−1.5 to +1.0	10^{-5}	—	—	—	Yes	40
Pd/MoTe ₂ /MoS ₂ /(Cr/Au) (Lateral)	—	—	−6.0 to +6.0	3.0×10^{-12}	$> 10^5$	46	$\sim 10^9$	No	41
(Cr/Au)/n-ReS ₂ /p-Si (Vertical)	—	80 μs	−1.0 to +1.0	0.2×10^{-9}	7.5	33470	—	No	42
(Ti/Au)/MoS ₂ /(Ti/Au) (Lateral)	Both	—	−1.5 to +1.5	—	—	—	—	Yes	43
(Ti/Au)/SnS ₂ /n-Si (Vertical, GB)	Electrical	—	−10.0 to +8.0	—	—	—	—	Yes	44
Pd/ReS ₂ /Pd (Lateral)	Optical	33.4/36.7 (s)	−10.0 to +10.0	10^{-6}	3	133.4	3.4×10^9	Yes	7
Au/MoS ₂ /Au (Lateral)	Optical	256/139 (ms)	−1.0 to +1.0	0.8×10^{-9}	1.2×10^3	27340	1.1×10^{12}	No	This work
Au/GB-MoS ₂ /Au (Lateral, GB)	Optical	12.9/31.7 (s)	−1.0 to +1.0	1.1×10^{-9}	1.9×10^2	7640	2.3×10^{11}	Yes	This work

Fig. 5b. Fig. 5c and 5d illustrate the subsequently recorded electrostatic frictional force images in terms of EFM amplitudes under light illumination with sample biases of 0 V and 1.0 V, respectively. Notably, the image contrast of MoS₂ domains is found to be uniform between the contacts at 0 V sample bias, as represented by a line profile (blue coloured), as shown in Fig. 5e, which is extracted along the shaded region shown in Fig. 5c. However, the domain contrast changed sharply upon

applying a sample bias of +1.0 V. The domain near the biased electrode was much brighter than the grounded one due to the confinement of holes in the valence band by the barrier produced in the presence of GB, which is explained using the energy band diagram in the next section. The line profile (red coloured) illustrated in Fig. 5e extracted along the shaded region in Fig. 5d clearly resembles this, such as an increase in electrostatic frictional force near the biased electrode due to

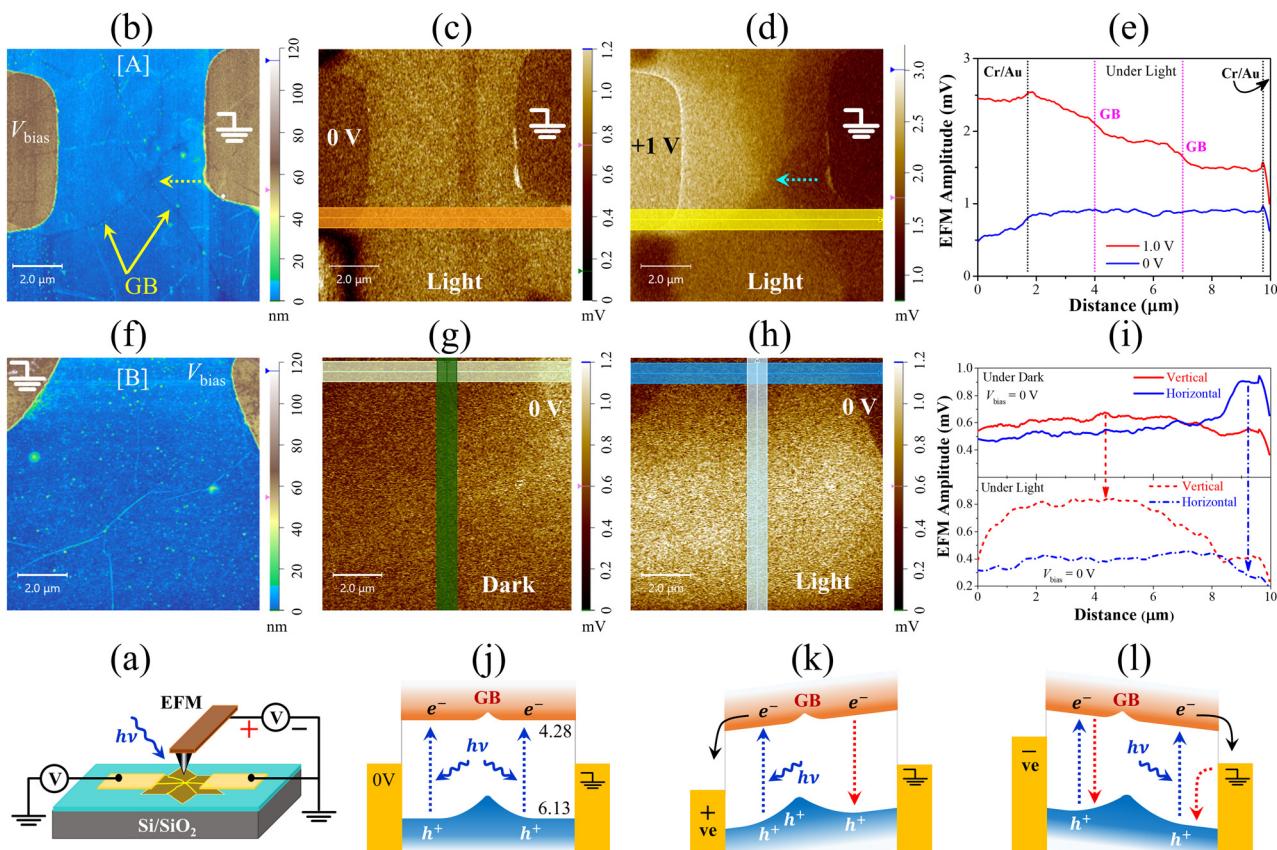


Fig. 5 Electrostatic force microscopy (EFM) analysis of devices [A] and [B] accompanied by potential energy band diagrams corresponding to various testing conditions. (a) Schematic representation of the EFM technique with applied sample bias. (b) AFM topography image of [A] highlighting GBs with arrows and sample biasing connection by ground symbol and V_{bias} . (c) and (d) EFM surface potential map images of [A] under light illumination at V_{bias} of 0 V and 1.0 V, respectively. The arrow in (d) indicates the confluence point of multiple GBs. (e) Line profiles extracted along the marked lines on (c) and (d). (f) AFM topography of [B] highlighting sample biasing connection. (g) and (h) EFM surface potential map images of [B] under dark and light illumination at V_{bias} of 0 V. (i) Line profiles extracted along the marked lines on (g) and (h) under dark (upper panel) and light illumination (lower panel). (j)–(l) Energy band diagrams of [A] with no bias, positive sample bias, and negative sample bias, respectively, by including the reduced bandgap at the GB of MoS₂.



charge confinement in the MoS_2 domain, which actually behaves as a confined charge puddle. A similar EFM study was conducted for device [B], in which Fig. 5f illustrates the AFM topography image along with the electrostatic force images at 0 V sample bias in dark and light illumination, as shown in Fig. 5g and h, respectively. The line profiles extracted from the long-shaded regions in Fig. 5g, both vertical and horizontal, are flat over the triangular ML MoS_2 sample, as shown in the top panel in Fig. 5i. A similar analysis for Fig. 5h shows photo-generated charge accumulation away from the region between the electrodes, as depicted in the lower panel in Fig. 5i.

Further insights into the role of GBs in the electrostatic force mapping images of [A] are provided, considering the energy band diagram optimized from the photoluminescence (PL) data analysis over the GB region and away. Fig. 5j illustrates the energy band diagram with a GB at the middle for $V_{\text{bias}} = 0$ V under light illumination, which depicts photocarrier generation and recombination occurring all over the sample surface. The electrostatic force image contrast should be uniform, as shown in Fig. 5c. In contrast, Fig. 5k displays significant evidence of confining the photo-generated holes upon applying +1.0 V to the left electrode, which helps to drain out the photo-generated electrons from the left MoS_2 domain, and the electrostatic force mapping image appears bright (Fig. 5d). However, the energy barrier created by the GB over the energy bands restricts electrons to cross and recombine, which makes the MoS_2 domain near the grounded electrode neutral. Accordingly, the electrostatic force mapping image appeared darker in contrast. Following this convention, the contrast of both the MoS_2 domains across the GB would be similar for a sample bias

of -1.0 V, as illustrated in Fig. 5l, due to photo-generated charge carrier recombination in both domains. Interestingly, the EFM study under light illumination by applying a sample bias voltage of -1.0 V resulted in a similar result, as illustrated by the recorded electrostatic force images and line profiles in Fig. S7 in the ESI.† The role of GB in inducing a barrier inside the valence and conduction band for the holes and electrons is truly emphasized by our EFM results and corresponding energy band diagram analysis.²¹

2.4. Photonic neuromorphic developments of MoS_2 photodetector

The emulation of photonic synapses represents an interdisciplinary effort at the intersection of photonics, neuroscience, and information processing, with the potential to revolutionize neuromorphic computing and related technologies.^{9,22} Fig. 6a schematically depicts the activity of the photonic synapse in the brain, starting from the conversion of optical signal to electrical signal and subsequent modulation of synaptic connection or weight after transmission through the optic nerve between eyes and brain. A typical circuit using our Au/GB MoS_2 /Au photodetector for recording synaptic activities is also shown schematically in Fig. 6b, which actually replicates a biological synapse analogically. An excitatory post-synaptic current (EPSC) is a phenomenon in neuroscience that plays a crucial role in the synaptic transmission of action potential and neural communication within the nervous system. EPSCs are responsible for transmitting excitatory signals from one neuron to another through intermediate ionic events into the synaptic cleft, ultimately influencing neuronal firing and information processing in the brain.¹³ Fig. 6c depicts a typical EPSC response

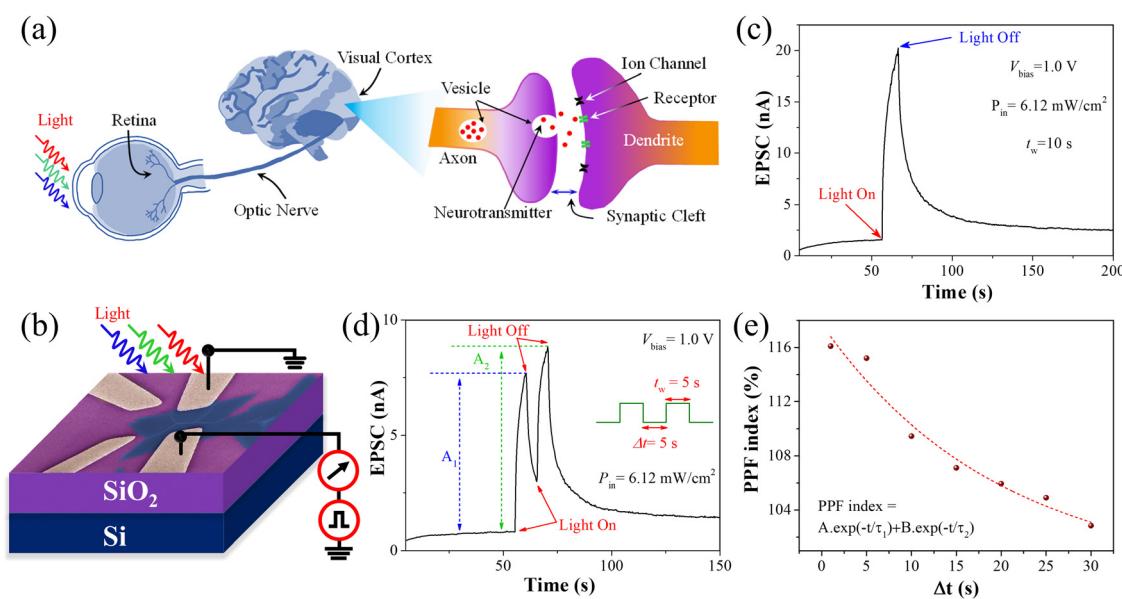


Fig. 6 (a) Schematic illustration of a biological synapse analogue with the Au/GB MoS_2 /Au photodetector as an artificial photonic synapse in the brain. (b) Circuit connection for [A] to mimic photonic synaptic activity. (c) Recorded excitatory postsynaptic current (EPSC) triggered by a light pulse of width 10 s with an intensity of 6.12 mW cm^{-2} . (d) Demonstration of paired-pulse facilitation (PPF) using a pair of light pulses with an intensity of 6.12 mW cm^{-2} and an applied sample bias of 1.0 V. Inset shows the schematic of applied paired light pulses with $t_w = 5$ s maintaining a temporal interval Δt of 5 s. (e) PPF index as a function of time interval (Δt) between light pulses for a light intensity of 6.12 mW cm^{-2} .



recorded from our GB MoS₂ device using a light pulse of the intensity of 6.12 mW cm⁻² and width (t_w) of 10 s in terms of measured post-synaptic photocurrent at an applied $V_{bias} = 1.0$ V. It shows a significant enhancement of the photocurrent as the post-synaptic signal during the period of the incident light pulse. Significant EPSC response modulation was observed for the same light intensity by varying the pulse period, as illustrated in Fig. S8 in the ESI.† This characteristic is essential for mimicking synaptic actions of higher orders, such as paired-pulse facilitation (PPF), spiking timing-dependent potentiation (STDP), and short- and long-term potentiation (STP and LTP).¹⁰

PPF is a phenomenon observed in neural synapses, where the second of two closely spaced stimuli elicits a larger post-synaptic response than the first. Understanding and manipulating PPF in photonic devices could have implications for the development of optical computing, neuromorphic computing, or other advanced technologies that aim to replicate certain aspects of neural processing artificially. Fig. 6d illustrates a typical PPF response recorded using our GB MoS₂ device using two consecutive light pulses of width 5 s, with a time interval gap (Δt) of 5 s between them. It shows a potentiation of the EPSC value for the second light pulse (A_2) compared with the first one (A_1), which is used to estimate the PPF index $\left(= \frac{(A_2 - A_1)}{A_1} \times 100\% \right)$ for the $\Delta t = 5$ s. Accordingly, the PPF indexes were calculated for different values of Δt , as graphically

depicted in Fig. 6e, which nicely follows a double exponential decay function similar to Kohlrausch law, as given below (eqn (1)):⁹

$$\text{PPF index} = C_1 \exp\left(-\frac{\Delta t}{\tau_1}\right) + C_2 \exp\left(-\frac{\Delta t}{\tau_2}\right), \quad (1)$$

where C_1 and C_2 represent two constants, and τ_1 and τ_2 represent two different relaxation times involved with neural signal decay. Fig. 6e illustrates a stronger facilitation of EPSC and a larger PPF index for shorter Δt values, which gradually diminishes to larger Δt values. Curve fitting using eqn (1) with our experimental PPF index values was obtained. The relaxation time constants are found to be about 20 s for both the τ_1 and τ_2 after performing curve fitting using eqn (1) with our experimentally measured PPF index values for different Δt values, as depicted in Fig. 6e, which are found realistic with some biological brains around us. A similar PPF test was performed for [B], and no response of emulation PPF response is observed, as shown in Fig. S9 in the ESI.† In fact, our device [A] also depicted the interesting phenomenon of the Atkinson and Shiffrin memorization model proposed in 1968 when using pulses of green laser ($\lambda = 532$ nm) of power 327 $\mu\text{W cm}^{-2}$. It shows a transition from short-term memory (STM) to long-term memory (LTM) by increasing the pulse number from 2 to 15, as illustrated in Fig. S10 in the ESI.†

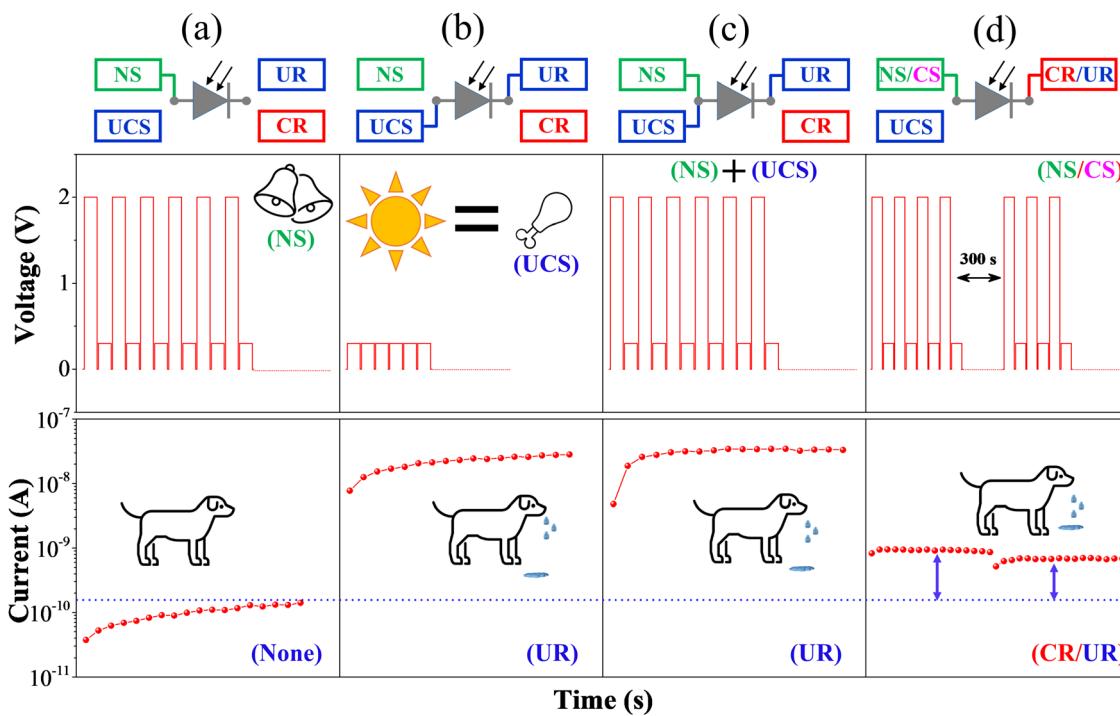


Fig. 7 Demonstration of classical conditioning of the brain using the six-point star 2D MoS₂ photodetector or [A] by mimicking Pavlov's dog experiment. The top panels outline the essential steps, showcasing potential combinations of input stimuli and resulting responses using the photodetector symbol. The middle panels depict all four combinations of stimuli, involving a bell (neutral stimulus, NS) and food (unconditioned stimulus, UCS). The bottom panels showcase the corresponding responses by recording the current at the output and parallel postures of a dog. (a) Influence of the NS on the output current. (b) Effect of the UCS. (c) Combined effects of UCS and NS. (d) Influence of NS post-training with (NS + UCS) and the transformation of NS into the conditioned stimulus (CS).



2.5. Classical conditioning in the brain or adaptive learning
 With the aforementioned advancements, devices capable of generating effects similar to classical conditioning play a crucial role in advancing our understanding of the brain. They contribute to improving therapeutic interventions, enhancing cognitive abilities, modifying behaviors, and facilitating immersive learning experiences in various domains. Classical conditioning, a form of associative learning, was systematically studied by Ivan Pavlov, a Russian physiologist, in the late 19th century. In this process, a neutral stimulus (NS) is paired with an unconditioned stimulus (UCS) to evoke a conditioned response (CR). Over time, the neutral stimulus (NS) is transformed into a conditioned stimulus (CS) capable of eliciting the conditioned response (CR).^{15,46} Our study, depicted systematically in Fig. 7 using the GB MoS₂ optoelectronic device, parallels Pavlov's classical conditioning experiment. In Fig. 7a, the top panel illustrates a voltage pulse train (middle panel) with an amplitude of +2.0 V and a width of 2 s, serving as the NS input—analogous to the bell sound in Pavlov's dog experiment. The output, recorded as zero response (bottom panel), mimics the absence of salivation. Subsequently, light pulses (middle panel) function solely as the UCS input, akin to the presentation of food, resulting in an unconditioned response (UR) recorded in the bottom panel in Fig. 7b. Notably, the UR exhibits a significant change, reminiscent of the initiation of salivation in dogs responding to the UCS input. In the next phase, both the NS and UCS inputs are utilized to train [A], and the corresponding output records the UR. This training phase reproduces a salivation-like effect in dogs, as systematically illustrated in the panels in Fig. 7c. Finally, using the NS replicating the bell sound as the sole input yields a significant change in the output, which is identified as the conditioned response (CR). This CR is equivalent to the UR or salivation of dogs, even in the absence of food. This result indicates the successful conversion of the NS, akin to the bell sound, to a CS—equivalent to the perception of food, as depicted schematically in the top panel in Fig. 7d. Consequently, our GB MoS₂ optoelectronic device successfully replicates Pavlov's dog experiment, showing its potential for designing hardware that mimics classical conditioning in the brain.

3. Conclusion

In conclusion, this study highlights the transformative potential of layered 2D materials with grain boundaries (GBs) across various applications. Despite significant advancements in the field, deliberately incorporating GBs during the growth of 2D materials remains a challenge. Through our investigation into the significance of GBs in monolayer molybdenum disulfide (ML MoS₂), particularly in terms of optoelectronic functionalities, such as photodetection, photonic synaptic behaviors, and brain-like adaptive learning, we reveal valuable insights. Our comparative analysis underscores the superior performance of GB-free MoS₂ devices in photodetection, with remarkable characteristics, including a high dark-to-light current ratio, responsivity, detectivity, and noise equivalent power, surpassing devices containing GBs in MoS₂.

Additionally, our findings reveal that GBs significantly delay the response speed, indicating the presence of persistent photoconductance (PPC), which poses a major challenge for practical applications. To overcome this, further efforts are needed to enhance the response speed by optimizing the material selection and device architecture. Interestingly, we observe that GBs facilitate the emulation of various photonic synaptic behaviors and demonstrate photonic adaptive learning in MoS₂, marking an early indication of this phenomenon in the literature.

Furthermore, our experimental results shed light on the atomic-level structure of MoS₂ domains at GBs, highlighting their role as charge carrier recombination centers due to the presence of defects. Notably, GBs induce a barrier within the energy bands by shrinking the bandgap, thereby impeding the flow of the photogenerated carriers. Through a systematic elucidation of these phenomena using energy band diagrams and visualization techniques, such as electrostatic force microscopy, our study contributes to a deeper understanding of the complex interplay between grain boundaries and optoelectronic functionalities in 2D materials. Moving forward, addressing the challenges associated with the deliberate incorporation of GBs in 2D materials and leveraging their unique properties could pave the way for the development of advanced photonic memristor devices with enhanced performance and functionality.

4. Experimental method

4.1. Materials and chemicals

Molybdenum(vi) oxide (MoO₃, 99.97%), sulfur powder (S, > 99.5%), sodium chloride (NaCl, > 99%), 2-propanol (IPA, 99.5%), and acetone (99.5%) were purchased from Sigma Aldrich/Merck India and used as received without further purification. Si/SiO₂ (300 nm) wafers, purchased from Silicon Valley Microelectronics (SVM) Inc., USA, were used as the substrate to grow monolayer 2D molybdenum disulfide (MoS₂) flakes using the thermal chemical vapour deposition (TCVD) technique. Gold (Au, 99.999% purity) and chromium (Cr, 99.999% purity) were purchased from Testbourne Ltd, UK to deposit metal electrodes for electrical contacts. Deionized (DI) water from the Milli-Q Direct 8 system with a resistivity of 18.2 MΩ-cm was used to clean the substrates. Argon (Ar, 99.999% purity) was used as the carrier gas inside the CVD chamber during the growth process of MoS₂ monolayer flakes.

4.2. Monolayer MoS₂ growth

Monolayer 2D MoS₂ flakes were grown over various substrates (e.g., Si/SiO₂ or quartz) using the chemical vapour deposition (CVD) method with argon (Ar) and NaCl as the transport gas agent and seeding promoter. Briefly, Si/SiO₂ substrates of size 13 × 18 mm² were cut using a diamond scribe and cleaned by following the standard protocol using ultrasonication by placing them into IPA, acetone, and DI water. The substrates were dried after cleaning under a stream of dry air and treated with oxygen (O₂) plasma at a set power of 95 W using a plasma cleaner tool of model number HPT 100 procured from



Henniker Plasma, UK to remove the residual organics or any other contaminants. Then, the cleaned Si/SiO₂ substrates were loaded inside the CVD chamber, which was a quartz tube with a length of 1 m and an outer diameter of 80 mm, and placed on a ceramic boat kept upside down with a gap of 10 mm between the two, as illustrated schematically in Fig. S1 in the ESI.† The next step was to load the precursors S and Mo with the seeding promoter NaCl into the quartz tube of the CVD system procured from VT Vacuum Technologies (P), Ltd, Bangalore. Typically, 10 mg of molybdenum(vi) oxide powder was placed in the middle of a ceramic boat located at the center of heating zone 2 (rightmost downstream). Then, NaCl was placed in the same ceramic boat, maintaining a gap of about 10 mm upstream from the first substrate. Then, a quartz boat ($L \times W \times H$: 50 mm \times 12 mm \times 8 mm) carrying sulfur powder of weight 500 mg was placed inside the CVD chamber (quartz tube) at the centre of heating zone 1, maintaining a 300 mm distance from the MoO₃ toward upstream. Then, the CVD chamber was sealed and evacuated for 1 hour at a pressure of 3 Torr (4 mbar). Next, the CVD chamber was purged using ultra-high pure (UHP) Argon (Ar) gas at a 500 sccm flow rate to remove the residual oxygen and moisture from the chamber. Before heating up the chamber, the deposition pressure was set to 740 Torr, with the carrier gas flow rate at 500 sccm. In the next step, the temperature of zone 2 was ramped to 375 °C at a heating rate of 15 °C min⁻¹ from the room temperature and maintained for 30 min to reach thermal equilibrium. To initiate the monolayer 2D MoS₂ growth, the heating zones were programmed in such a way that they should attain a set temperature of 600 °C, and the temperature near the sulfur source is nearing 250 °C simultaneously using a ramp rate of 5 °C min⁻¹ and maintained to those values for 20 minutes to facilitate the MoS₂ growth. During the temperature ramping process, the Ar flow inside the reaction chamber was also reduced gradually from 500 sccm to 20 sccm and was maintained for the rest of the process to cool the chamber naturally at room temperature. Then, the substrates with MoS₂ flakes were removed from the chamber and used for further characterization and device fabrication.

4.3. Device fabrication

The device fabrication step involved the deposition of micro-electrodes (Cr/Au) using the photolithography technique on the *in situ* MoS₂ flakes of different shapes, six-pointed star and triangular, using Heidelberg μPG 501 maskless system for writing the electrode patterns. First, monolayer 2D MoS₂ deposited Si/SiO₂ (300 nm) substrates were treated using SurPass 4000 as a priming agent at a spinning speed of 4000 rpm for 30 s and washed in running DI water for 60 s, followed by a drying step using nitrogen stream. Then, the SurPass-treated MoS₂ sample substrates were coated with a positive photoresist (AZ 5214) layer at a spinning speed of 4000 rpm for 45 s, followed by a soft baking step at 100 °C for 60 s. After cooling, the photoresist-coated substrates were exposed to a UV laser line of 365 nm wavelength at a set power of 110 mJ for 8 s to write the desired pattern. After patterning,

substrates were dipped into an MIF 726 developer solution for 20 s precisely, then rinsed with DI water and dried under N₂ gas. Then, the developed patterns after a baking step (110 °C for 60 s) were inspected carefully under a microscope to confirm the high yield of pattern transfer and kept inside a thermal vacuum evaporation system (V R Technologies, Bangalore) for metallization. Finally, 80 nm thick gold (Au) with a 5 nm chromium (Cr) adhesion layer was deposited when the chamber pressure reached $\sim 10^{-6}$ mbar. After that, the metallized substrates were dipped into an MLO 07 stripper solution overnight for the lift-off process, which resulted in Si/SiO₂ substrates with patterned electrodes on the *in situ* monolayer 2D MoS₂ flakes.

4.4. Material characterizations

Preliminary inspection of the growth of 2D MoS₂ flakes and their lateral size and shape evolution was performed by recording optical images using an Olympus BX53 fluorescence microscope. Raman scattering results and photoluminescence (PL) properties, including PL and Raman mapping of *in situ* MoS₂ flakes on Si/SiO₂, were recorded under ambient conditions using a Horiba Scientific XploRA PLUS confocal Raman microscope with 532 nm laser excitation, a long working distance 100X objective (N.A 0.7), and 1800 lines per mm and 600 lines per mm gratings, with acquisition and integration time of 5 s. Excitation laser power was set to 10 mW with a spot size of 0.7 μm to record the scattering spectra of MoS₂ flakes. The morphology and thickness of the MoS₂ flakes were identified by recording atomic force microscope (AFM) images using JPK NanoWizard@ 4 NanoScience AFM from Germany in tapping mode with a cantilever of force constant 48 N m⁻¹ and resonance frequency 169 KHz. Scanning electron microscope (SEM) images were also recorded using a Nova NANOSEM 450 tool to probe the morphology of CVD-grown MoS₂ monolayer flakes on Si/SiO₂ substrates. The X-ray photoelectron spectroscopy (Omicron nanotech XPS) technique was used to determine the elemental compositions of the CVD-grown MoS₂ samples. The polycrystalline structure and grain boundaries were imaged precisely using a Titan Themis 300 kV transmission electron microscope (TEM) procured from ThermoFisher Scientific, USA.

4.5. Optoelectronic characterizations

Normal and transient current–voltage (*I*–*V*) characteristics under dark and light illumination for both the planer Au/MoS₂/Au photodetector devices with six-pointed star-shaped and triangular flakes were recorded inside a Janis ST 500 probe station with a top quartz window and coupled with a Keithley 4200 semiconductor characterization system. An SS-F5-3A solar simulator procured from Enlitech, Taiwan was used as the light source to study the photodetection, artificial photonic synapse, and adaptive learning (classical conditioning) properties/behaviours by tuning the incident light power and irradiation width. Manually chopped light pulses were generated to record the temporal photoresponse.

To demonstrate adaptive learning, we conducted trials analogically similar to the famous Pavlov's dog experiment by



employing electrical pulses as the neutral stimulus (NS) and chopped light pulses as the unconditional stimulus (UCS). A Keithley 4200-SCS instrument equipped with a pulse measuring unit (PMU) was used to apply the required input electrical pulses to the photodetector device [A] or [B] (MoS_2 with GB or without GB) and to measure the device current response at the output by a small reading voltage pulse. We used voltage pulses of +2 V, 1 s as the neutral stimulus (NS), followed by a reading voltage pulse of +300 mV, 1 s with a pre- and post-delay of 100 ms to record the unconditional or conditioned response (UR or CR). This was considered one cycle of training using NS, which was repeated to train the device for learning. For the unconditional stimulus (UCS), we used chopped light pulses with an intensity of 6.12 mW cm^{-2} and recorded the corresponding UR using read voltage pulses. Next, we used both the NS and UCS to train the device and record the response current. Finally, we used the NS only and recorded the current response similarly using read pulses as the conditioned response (CR), which is similar to UR.

4.6. Electrostatic force microscopy (EFM)

Further, we studied the effect of grain boundaries on the optoelectronic properties of MoS_2 by employing dynamic contact electrostatic force microscopy (DC-EFM) using Park NX-7. A conductive probe tip ElectriMulti75-GM has an electrically conductive coating of 5 nm Cr and 25 nm Pt with a force constant ($k = 3 \text{ N m}^{-1}$) and resonance frequency ($f_{\text{resonance}} = 75 \text{ kHz}$). A drive frequency of 17 kHz with a drive amplitude of 1.0 V is applied to the tip during EFM measurements. The electrostatic friction was measured while applying 0 V, +1.0 V and -1.0 V biases to one of the electrodes, and the other electrode was grounded.

Author contributions

B. C. D. and N. K. K. conceptualized the idea and designed the experiments. N. K. K. was responsible for material growth, device fabrication, and data curation. S. S. and N. K. K. jointly curated the biased EFM data. B. C. D., with the assistance of S. S. and N. K. K., analyzed the EFM data. Both B. C. D. and N. K. K. contributed to the formal data analysis and drafted the original manuscript. B. C. D. oversaw the project and secured funding. All authors were involved in the discussion of research progress, collaborated on key decisions, and collectively revised the manuscript.

Data availability

The data supporting this article are included in the ESI.†

Conflicts of interest

The authors declare no conflict of interest.

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